



Atty. Dkt. No. 039262-0165

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant: Tadahiro OHMI et al

Title: PLASMA PROCESSING METHOD AND METHOD FOR  
MANUFACTURING AN ELECTRONIC DEVICE

Appl. No.: 10/594,895

Filing Date: 11/07/2006

Examiner: Valerie N. Brown

Art Unit: 2829

Confirmation 8302

Number:

**AMENDMENT AND REPLY UNDER ACCOMPANYING RCE**

Mail Stop RCE  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450  
Sir:

This communication is responsive to the Final Office Action dated December 15, 2009, concerning the above-referenced patent application. Applicants have enclosed with this amendment a Petition for Extension of Time to make this response timely.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this document.

**Remarks/Arguments** begin on page 3 of this document.

Please amend the application as follows: